June 9, 2023

**Regarding the Kobayashi-Uchiike-Mikoshiba Prize**

Haruhiko Okumura

President

International Display Workshops General Incorporated Association

Outline

The International Display Workshops (IDW) is supported, develops and continues to make contributions to society through the lively activities of its participants, centering on those who give presentations. The foundations of IDW are their contributions resulting from pioneering achievements in participants’ disciplines and technical aspects, contributions resulting from the nurturing of human resources capable of being active in IDW through education and technical instruction, and contributions resulting from enthusiastic involvement in the operation of IDW. In recognition of these past contributions, the Kobayashi-Uchiike-Mikoshiba Prize is awarded with the intention of expressing respect and gratitude to those who have made particularly notable contributions, and in the hope that they will continue for long into the future to remain at the center of IDW activities, and contribute not only to their development but also to society as a whole.

Nomination regulations

Each scope is divided into the following three areas, and one candidate from each of these areas can be chosen (approximately 0.2% on the basis of 1,300 participants.)

NB: The Workshops are for referential purpose, and it is acceptable for a different area to be chosen.

1. Materials-related：LCT、MEMS (MEET)、PH、FMC etc.
2. Devices-related：AMD、OLED、EP、FLX、FMC etc.
3. Systems-related：3D、VHF、PRJ、DES、INP etc.
4. Prerequisites for candidates

Candidates must satisfy all of the following prerequisites.

・They must have submitted papers, which have been accepted, at five or more IDWs (including co-authored papers)

・They must have performed a pioneering engineering or scientific role in

・They must have made a significant contribution to the operation of IDW

However, candidates cannot be IDW directors or persons connected with the Awards Committee as below:

 ・IDW General Incorporated Association directors or auditors

 ・Chair or members of the Awards Committee

1. Prerequisites for nominators

・Personnel of the IDW General Incorporated Association, or either a Workshop Chair, Workshop Program Chair or Workshop General Secretary.

NB: Nominations must have the recommendation of at least three other persons, and self-nominations will not be accepted.

(3) Nomination method

Send the nomination form (including the three or more recommendations) to the following e-mail address by July 28th.

 Where to send nomination documents:

 Send the nomination documents to: Chair of the Awards Committee and IDW General Incorporated Association director: Mutsumi Kimura: mutsu@rins.ryukoku.ac.jp

**How to complete the Nomination Form**

Title: “2023 Kobayashi\_Uchiike\_Mikoshiba Prize Nomination”

1. Nominee information: Detail the information on the candidate (name, place of employment and position, address, telephone number, fax number and e-mail address etc.)
2. Proposed citation: Detail the reason for nomination in 30 words or less (including area).
3. Education and professional history: Write the nominee’s itemized curriculum vitae in chronological order. Emphasize positions of authority regarding work, missions and in particular any items subject to awards
4. List of main papers presented in IDW, minimum five papers. Professional Awards and Other Professional Society Affiliations and Grades of Membership: List of five or more presentations at IDW, record of awards, activities outside of main work cited above, contributions made to operation of the IDW societies, contributions made to other societies of which nominee is member and the operations thereof, and any other relevant information

(1)

(2)

(3)

(4)

(5)

1. Description of most significant achievement(s) or of outstanding technical leadership: state achievements related to content of prize. This is the most important item in screening, so in order to make an adequate appeal state these quantitatively, and in an easily understood and well-arranged manner. With regard to important points, add any related items to which the following apply. The degree of technical contribution made by candidates themselves is vital. Managerial contributions are hardly evaluated. Candidates should be referred to as either he/she or Mr. /Mrs XXX.
2. Supportive Material: list of related papers/books (mark the important literature with annotations, including any co-authors), and number of related patents. (Add an outline for important items, adding annotations on efficacy etc. Do not count overseas and domestic patents separately.)
3. Nominator Information: At least three persons, preferably as many as possible, including their names, affiliations and e-mail addresses.

(1)

(2)

(3)

Complete nominations in English or Japanese, and please keep them within four to eight pages in length in A4 format or equivalent.